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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kanshi CHINONE et al.**

Group Art Unit: **3723**

Serial Number: **10/568,147**

Examiner: **Not yet assigned**

Filed: **February 13, 2006**

Confirmation Number: **7793**

For: **POLISHING SLURRY FOR SEMICONDUCTOR PLANARIZATION**

Attorney Docket Number: **062110**

Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. 1.97(b)

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

March 13, 2007

Sir:

Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non- U.S. document is attached.

This paper is being filed prior to issuance of a first action on the merits and within the time periods set forth in 37 C.F.R. §1.97(b). A copy of each non-U.S. document is enclosed herewith.

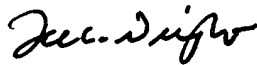
In further compliance with the concise explanation requirement under 37 CFR §1.98(a)(3), JP2003-188122 is cited and discussed the enclosed Office Action in a corresponding foreign application.

JP2003-188122 was previously listed in the IDS filed June 27, 2005 and is not resubmitted herein. US 6,221,118 and EP0939431 are related to JP10-154673, previously listed in the IDS filed June 27, 2005.

Information Disclosure Statement under 1.97(b)
Attorney Docket No. 062110
Serial No. 10/568,147

If there are any fees due in connection with the filing of this paper, please charge Deposit
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Respectfully submitted,
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Enclosures: PTO/SB/08
Document(s)



Combined Form PTO/SB/08A&B

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Complete if Known

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|------------------------|-----------------------|
| Application Number | 10/568,147 |
| Confirmation Number | 7793 |
| Filing Date | February 13, 2006 |
| First Named Inventor | Kanshi CHINONE et al. |
| Art Unit | 3723 |
| Examiner Name | Not yet assigned |
| Attorney Docket Number | 062110 |

Sheet 1 of 1

U.S. PATENT DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Document Number | | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document |
|--------------------|-----------------------|-----------------|--------------------------------------|--------------------------------|---|
| | | Number | Kind Code ² (if known) | | |
| | 1. | US 6,221,118 | B1 | 04-24-2001 | Yoshida et al. |
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FOREIGN PATENT DOCUMENTS

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| | 2. | EP | 0 939 431 | A1 | 09-01-1999 | HITACHI CHEMICAL CO., LTD. | |
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NON PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published. | Translation ⁶ |
|--------------------|-----------------------|--|--------------------------|
| | 3. | Korean Office Action dated December 8, 2006, issued in corresponding Korean Patent Application Number 10-2006-7002813. | Full |
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Examiner Signature

Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to indicate here if English language Translation is attached.